IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2817
Koji Naniwada	Examiner: Dean O. Takaoka
Application No. 10/595,666	Confirmation No.: 4359
Filed: May 3, 2006)
For: MICRO-RESONATOR AND COMMUNI APPARATUS	ICATION))

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RE-SUBMISSION OF TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT CITED IN A COMMUNICATION FROM A FOREIGN PATENT OFFICE

In accordance with the provisions of 37 C.F.R. §§1.56 and 1.98, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form be made during the course of examination of the above-referenced application for United States Letters Patent. The references were cited in an Information Disclosure Statement which was filed on September 18, 2008 with the USPTO. However, one of the references cited did not include a date.

Applicants hereby resubmit a PTO/SB/08a form with the following correction to a Non-Patent Literature Document originally cited on September 18, 2008:

CLARK T.C. NGUYEN, "RF Mems for Wireless Applications," Center for Wireless Integrated Microsystems (WMS), University of Michigan, 2002.

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A copy of the Search Report also is enclosed.

Respectfully submitted,

Dated: December 1, 2008 By: /David R. Metzger/

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